

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 118319		APPLICATION NO. 10/765,200	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANT Mutsumi KIMURA			
				FILING DATE January 28, 2004		GROUP 2818	

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS

FOREIGN PATENT DOCUMENTS						
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
PD	1.	JP A 11-282995 w/Abstract and Translation	10/15/1999	Japan	—	—

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)						
PD	2.	S. Utsunomiya et al., "Low Temperature Poly-SI TFT-LCD Transferred onto Plastic Substrate Using Surface Free Technology by Laser Ablation/Annealing (SUFTLA [®]), Asia Display/IDW '01, pages 339-342				

EXAMINER <div style="text-align: center; font-family: cursive;">PHUC T. DANG</div>	DATE CONSIDERED <div style="text-align: center; font-family: cursive;">3/8/06</div>
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Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.